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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: David Skee

Serial No. 10/572,860

Title: ALKALINE, POST PLASMA ETCH/ASH RESIDUE REMOVERS AND  
PHOTORESIST STRIPPING COMPOSITIONS CONTAINING METAL-  
HALIDE CORROSION INHIBITORS

Filed: February 23, 2006

Examiner: Webb, Gregory E.

Art Unit: 1796

Confirmation No.: 3653

Customer No.: 24,289

Attorney Docket No.: 1595 WO/US

**MAIL STOP: AMENDMENT**

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT RESPONSE TO JUNE 4, 2009 OFFICE ACTION**

Honorable Commissioner for Patents:

This Amendment Response is filed in reply to the Office Action dated June 4, 2009.

The **Listing of Claims** starts in the Section beginning at page 2 of this Response.

The **Remarks** start in the Section beginning at page 8 of this Response.